

Attorney Docket No. 03663/LH

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**IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE**

Date of Deposit: November 3, 2003

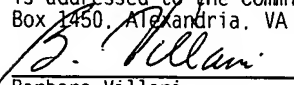
Applicant(s): T. MATSUZAKI et al

Serial No. : Not yet assigned

Filed : Herewith

For : WIRING STRUCTURE ON  
SEMICONDUCTOR  
SUBSTRATE AND  
METHOD OF  
FABRICATING THE SAME

I hereby certify that this paper is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

  
Barbara Villani

In the event that this Paper is late filed, and the necessary petition for extension of time is not filed concurrently herewith, please consider this as a Petition for the requisite extension of time, and to the extent not tendered by check attached hereto, authorization to charge the extension fee, or any other fee required in connection with this Paper to Account No. 06-1378.

Art Unit :  
Examiner :

**INFORMATION DISCLOSURE STATEMENT**

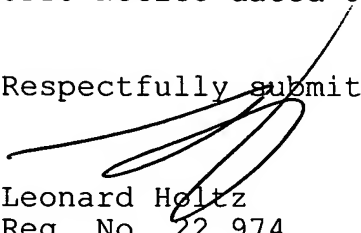
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S I R :

It is respectfully requested that the documents listed on the attached form PTO/SB/08A be considered and made of record. The document is identified on page 2 of the present specification.

The U.S. patent publication identified on said form PTO/SB/08A is not enclosed herewith since the USPTO waived the requirement to file copies of U.S. patents and U.S. patent application publications for U.S. applications filed after June 30, 2003. See the USPTO Notice dated July 11, 2003.

Respectfully submitted,

  
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PTO/SB/08A (08-00)

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Substitute for Form 1449A/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>				Application Number		
				Filing Date		Herewith
				First Named Inventor		MATSUZAKI
				Group Art Unit		
				Examiner Name		
Sheet	1	of	1	Attorney Docket Number		03663/LH

### U.S. PATENT DOCUMENTS

Exam. Inits <sup>1</sup>	Cite No <sup>1</sup>	Document Number	Kind Code <sup>2</sup>	Name of Patentee or Applicant	Publication Date MM-DD-YYYY	Relevant Portion
		6,600,234	B2	Kuwabara et al	07-29-2003	

### FOREIGN PATENT DOCUMENTS

Exam Inits <sup>1</sup>	Cite No <sup>1</sup>	offc <sup>3</sup>	Document Number <sup>4</sup>	Kind Code <sup>5</sup>	Name of Patentee or Applicant	Publication Date MM-DD-YYYY	Relevant Portion	T <sup>6</sup>

Examiner  
Signature

Date  
Considered

<sup>1</sup> EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>2</sup> Unique citation designation number. <sup>3</sup> See kinds of U.S. Patent Documents. <sup>4</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>5</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>6</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>7</sup> Place a check here if English translation is attached.

DATE MAILED: November 3, 2003